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Date: Feb. 11, 2004

TO: Examiner Kin Chan Chen (703) 872-9311
Art Unit: 1756

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Subject Matter: 10/ 047,266 Attorney Doc: 67,200-641

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Applicant(s): Chih-Ming Ke

Application No.: 10/047,266 (CONF 4511)

Filed: 1/14/2002

Title: Reducing photoresist shrinkage via plasma
treatment

Attorney Docket No.: 67,200-641

Group Art Unit:
1765Examiner:
Kin Chan ChenCommissioner for Patents
Alexandria, VA 22313-1450Certificate of Facsimile Transmission

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Patent Office via facsimile no. (703) 872 9311 on the date shown below.

Date: Feb. 11, 2004
Kathy DixonREQUEST FOR RECONSIDERATION

Dear Sir:

In response to a final Office Action dated Dec. 11, 2003, please enter the following amendment and consider the following remarks.